



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2876

00862.022319

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ken MATSUMOTO

)  
: Examiner: L. M. Caputo

)  
: Group Art Unit: 2876

)  
: Confirmation No.: 5950

)  
:

) June 28, 2004  
: (Monday)

)

Application No.: 09/920,752

Filed: August 3, 2001

For: SUBSTRATE TRANSFER APPARATUS, SEMICONDUCTOR  
MANUFACTURING APPARATUS, AND SEMICONDUCTOR  
DEVICE MANUFACTURING METHOD

**Mail Stop AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment After Final Rejection in the above-identified application.

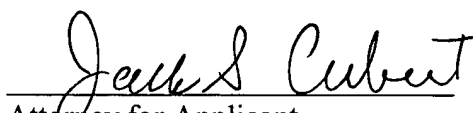
☒ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	10	MINUS	20	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	4	MINUS	5	= 0	x \$43 \$86	\$0.00
Fee for Multiple Dependent claims \$145/\$290						—
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00

- ☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$ \_\_\_\_\_ is enclosed including the additional claims fees.
- ☐ Charge \$ \_\_\_\_ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- ☐ A check in the amount of \$ \_\_\_\_ to cover the fee for a \_\_\_\_ month extension is enclosed.
- ☐ A check in the amount of \$ \_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicant's attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

  
Attorney for Applicant  
Jack S. Cubert  
Registration No. 24,245

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For: SUBSTRATE TRANSFER APPARATUS,	)
SEMICONDUCTOR MANUFACTURING	:
APPARATUS, AND SEMICONDUCTOR	) June 28, 2004
DEVICE MANUFACTURING METHOD	: (Monday)

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated April 26, 2004, the time for response being extended from Saturday, June 26, 2004 to Monday, June 28, 2004, please amend the above-identified application as follows, pursuant to 37 C.F.R. § 1.116: